

APPLICATION DATA SHEET

Electronic Version v14

Stylesheet Version v14.0

<b>Title of Invention</b>	METHOD OF DOUBLE-SIDED ETCHING
Application Type :	regular, utility
Attorney Docket Number :	TMIP0003USA
Correspondence address:	
Customer Number:	027765
	
Priority Data:	
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Inventor Information:	
<u>Inventor 1:</u>	
<b>Applicant Authority Type:</b>	Inventor
<b>Citizenship:</b>	TW
<b>Given Name:</b>	Chen-Hsiung
<b>Family Name:</b>	Yang
<b>Residence:</b>	
<b>City of Residence:</b>	Taipei Hsien
<b>Country of Residence:</b>	TW
<b>Address-1 of Mailing Address:</b>	2F, No. 1, Lane 61, Fenziwei St., Sanchung City
<b>Address-2 of Mailing Address:</b>	
<b>City of Mailing Address:</b>	Taipei Hsien
<b>State of Mailing Address:</b>	
<b>Postal Code of Mailing Address:</b>	
<b>Country of Mailing Address:</b>	TW
<b>Phone:</b>	
<b>Fax:</b>	
<b>E-mail:</b>	
Attorney Information:	
practitioner(s) at Customer Number:	
027765	
	

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